

Notice of References Cited	Application/Control No. 10/025,460	Applicant(s)/Patent Under Reexamination KARPINSKY ET AL.	
	Examiner Omar Rojas	Art Unit 2874	Page 1 of 1

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	B	US-6,549,703 ✓	04-2003	Tanielian et al.	385/33
	C	US-2002/0105699 ✓	08-2002	Miracky et al.	385/14
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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